IN THE CLAIMS

We claim:

1. A photoacid generator, comprising:

an antenna group; and a carborane-based group.

- 2. The photoacid generator of claim 1, wherein the carborane-based group is halogenated by between one and six halogens.
- 3. The photoacid generator of claim 2, wherein the carborane-based group is hexachlorocarborane.
- 4. The photoacid generator of claim 1, wherein the carborane-based group is functionalized on at least one boron atom by a group having a high electronegativity.
- 5. The photoacid generator of claim 1, wherein the carborane-based group is functionalized by an etch-resistant group.
- 6. The photoacid generator of claim 1, wherein the carborane-based group is functionalized on a boron atom by an alkyl group.
- 7. The photoacid generator of claim 1, wherein the carborane-based group is functionalized on a carbon atom by a group that modifies the polarity of the cationic carborane.

8. The photoacid generator of	ciaim 1, wherein the antenna group is diphenyllodonium.
 A composition, comprising a photoacid generator m a photoimageable specie a quencher. 	noiety comprising a carborane;
10. The composition of claim193nm photoresist.	9, wherein the composition is formulated to serve as a
11. The composition of claim EUV photoresist.	9, wherein the composition is formulated to serve as an
12. The composition of claim a wavelength of 13.5nm.	9, wherein the EUV photoresist is sensitive to light having
13. A composition, comprising a photoacid generator man a photoimageable specifical quencher; and the reaction products the	noiety comprising a carborane;
14. The composition of claim	13, further comprising an additive.
15. The composition of claim	14, wherein the additive is in the approximate range of 0.1

- 5% by weight of the composition.

- 16. The composition of claim 13, further comprising a solvent.
- 17. The composition of claim 16, wherein the solvent is in the approximate range of 1% 5% by weight of the composition.
- 18. The composition of claim 13, wherein the photoacid generator moiety comprising a carborane is in the approximate range of 0.1% and 5% by weight of the composition.
- 19. The composition of claim 13, wherein the photoacid generator moiety comprising a carborane is in the approximate range of 0.5% and 2.5% by weight of the composition.
- 20. The composition of claim 13, wherein the photoimageable species is a polymer.
- 21. The composition of claim 13, wherein the photoimageable species is in the approximate range of 80% and 97% by weight of the composition.

22. A method comprising:

improving the resolution of a photoresist by using a large volumed photoacid generator that produces a superacid when irradiated.

- 23. The method of claim 22, wherein the superacid is approximately four orders of magnitude more acidic than sulfuric acid.
- 24. The method of claim 22, wherein the large volumed photoacid generator is spherical-shaped.

25. A method comprising:

applying a photoresist to a substrate, the photoresist comprising a carborane-based photoacid generator;

patterning the photoresist by irradiating the photoresist; and etching the substrate.

- 26. The method of claim 25, wherein applying a photoresist to the substrate comprises applying a chemically amplified photoresist to the substrate.
- 27. The method of claim 26, wherein the chemically amplified resist is a high activation energy resist.
- 28. The method of claim 25, wherein patterning the photoresist by irradiating the photoresist comprises exposing the photoresist to light having a wavelength of 193nm.
- 29. The method of claim 25, wherein patterning the photoresist by irradiating the photoresist comprises exposing the photoresist to light having a wavelength in the extreme ultraviolet region of the spectrum.
- 30. The method of claim 29, wherein the wavelength in the extreme ultraviolet region of the spectrum is 13.5nm.